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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/794</b>	Application No. <b>10/533,607</b>	
	Applicant(s) <b>Tadashi ISHIKAWA, et al.</b>	Examiner <b>Mark L. SHEVIN</b>	
	Filing Date <b>November 3, 2005</b>	Confirmation No. <b>4087</b>	Art Unit <b>1793</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/MLS/	09-010985	01/14/1997	JP			Abstract	
/MLS/	08-174422	07/09/1996	JP			Abstract	

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
/MLS/	Japanese Office Action dated October 31, 2007 issued in corresponding Japanese Application No. 2002-315396

EXAMINER	/Mark L. Shevin/	DATE CONSIDERED	01/04/2009
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			